## EAST Search History

## EAST Search History (Prior Art)

Ref	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
1	2	"US 20070/245956"	US-PGPUB; USPAT; USOCR DERWENT	ADJ	ON	2009/09/28 10:46
1	1	(°6548121"),PN.	USPAT; USOCR	OR	OFF	2009/02/19 16:58
2	1180	"ciba specialty chemicals corporation" as	US-PGPUB; USPAT; FPPS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/19 18:03
3	5	"ciba specialty chemicals corporation" as. and strongly adherent coatings	US-PGPUB; USPAT; FPPS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/19 18:04
4	5	"ciba specialty chemicals corporation" as. and strongly adherent coating	US-PGPUB; USPAT; FPPS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/19 18:04
5	1	10.566743 app.	US-PGPUB; USPAT; FPRS; EPO; JPO; DEFWENT; IBM_TDB	ADJ	ON	2009/02/19 18:37
6	1	(77455891°), PNL	USPAT; USOCR	OR	OFF	2009/02/20 11:00
7	8	(("7455891") or ("6251963") or ("6486228") or ("6515051") or ("6803392") or ("6733847") or ("6548121") or ("6368362")).PN.	USPAT; USOOR	OR	OFF	2009/02/20 11:09
3	9	((7455891°) or ("6251963°) or ("6486228") or ("6515051") or ("6803392") or ("6733847") or ("6548121") or ("6368362") or ("639805"). PN.	USPAT; USOOR	OR	OFF	2009/02/20 11:14
9	108	["3669951"   "3936305"   "4082679"   "4199421"   "4226763"   "4246315"   "427504"   "4278589"   "4292152"   "4298738"   "4315448"   "4324744"   "4347180"   "4385109"   "4466993"   "4533652"   "4567106"   "4681905"   "469679"   "4684680"   "471523"   "4737583"   "4792832"   "4896191"   "46862481"   "4965284"   "4993364"   "5063246"   "5063946"   "5069994"   "5106895"   "5166355"   "5166348"   "5196142"   "5280104"   "5292890"   "5300539"   "55606260"   "5399770"   "5496349"   "546728"   "5472992"   "5504236"   "551614"   "5280424"   "49932842"   "5547466"   "559770"   "546728"   "5472992"   "5504236"   "55068850"   "5504236	US-PGPUB; USPAT; USCOR	ADJ	ON	2009/02/20 11:21
10	15	["4199421"   "4246315"   "4466993"   "4567106"   "4990364"   "5053246"   "5252403"   "6099122"   "6548121"   "6733847").PN. OR ("6548121"   "6733847"   "7455891").URPN.	US-PGPUB; USPAT; USOOR	ADJ	ON	2009/02/20 11:22

311	21169	427/533,535,536,517,407.1-412.5.532- 559,517,509,512,513,517,518,519,520,535,536,538,551,553,554,556,407.2,409,412,412.1,419.2 cds. or 430/311.cds.	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 11:27
512	5299	427/533,509.cds. or 430/311.cds.	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 11:27
13	211	(adhere\$4 or adhesion or glu\$3 or bond\$3) with metallized with (organic or polymer) with substrate	US-PGPUB; USPAT; FPPS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 12:30
14	139	(adhere\$4 or adhesion or glu\$3 or bond\$3) with metallized with (organic or polymer) with substrate and @PY< "2004"	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 12:30
15	13	(adhere\$4 or adhesion or glu\$3 or bond\$3) with metallized with (organic or polymer) with substrate and @PY<*2004" and S11	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 12:30
16	7	idrout and photoinitiator with adhesion with metal	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 16:56
17	183	circuit and photoinitiator with adhesion and (metal or copper)	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 17:11
18	13	circuit and photoinitiator with adhesion with (metal or copper)	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 17:11
19	613	circuit and photoresist with adhesion with (metal or copper)	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 17:18
20	283	dircult and photoresist with adhesion with (metal or copper) and plasma	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 17:18

S21	47	circuit and photoresist with adhesion with (metal or copper) with plasma	us-Pgpub; uspat; fpps; epo; jpo; derwent; ibm_tdb	ADJ	ON	2009/02/20 17:19
522	0	solder mask with (photopolymerizable or photoresist or photoinitiator or light sensitive or crosslink\$3 or UV) with adhesion with (metal or copper) with plasma	US-PGPUB; USPAT; FPPS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 17:34
23	0	solder mask with (photopolymerizable or photoresist or photoinitiator or light sensitive or crosslink\$3 or UV) and adhesion with (metal or copper) with plasma	US-PGPUB; USPAT; FPPS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 17:34
524	1116	solder mask with (photopolymerizable or photoresist or photoinitiator or light sensitive or crosslink\$3 or UV)	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 17:35
325	46	solder mask with (photopolymerizable or photoresist or photoinitiator or light sensitive or crosslink\$3 or UV) with adhesion	US-PGPUB; USPAT; FPPS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 17:35
326	10	solder mask with UV with adhesion	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 17:40
27	2	"20030129322".did.	US-PGPUB; USPAT; FPPS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 17:42
328	13	solder mask with (ovd or evaporate or pvd)	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 18:38
329	692	solder with (ovd or evaporate or pvd)	US-PGPUB; USPAT; FPPS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 18:41
330	5	solder with (ovd or evaporate or pvd) with (photopolymerizible or UV or photoinitiator or photoresist)	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 18:43

31	149	solder with (ovd or evaporate or pvd) and (photopolymerizible or UV or photoinitiator or photoresist)	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 18:44
32	12645	metal with (ovd or evaporate or pvd) and (photopolymerizible or UV or photoinitiator or photoresist)	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 18:44
33	45	solder with (ovd or evaporate or pvd) and (photopolymerizible or UV or photoinitiator or photoresist) and @PY<*2004*	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 18:44
34	580	circuit board and (metal or solder or contact or electrode or copper) with (ovd or evaporate or pvd) and (photopolymerizible or UV or photoinitiator or photoresist) and @PY< 2004*	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 18:57
35	25	circuit board and (metal or solder or contact or electrode or copper) with (cvd or evaporate or pvd) with (photopolymerizible or UV or photoinitiator or photoresist) and @P/< 2004*	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 18:57
36	3	wiring board and (metal or solder or contact or electrode or copper) with (ovd or evaporate or pvd) with (photopolymerizible or UV or photoinitiator or photoresist) and @PY<"2004"	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 18:58
37	121	circuit board and (metal or solder or contact or electrode or copper) with (ord or evaporate or pvd) and (photopolymerizible or UV or photoinitiator or photoresist) and @PY< "2004" and cmp	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/20 19:05
38	1	(°6524950°), PN	USPAT; USOOR	OR	OFF	2009/02/20 19:21
39	600	photoresist with (lift off or liftoff) and polymer\$2 with substrate and metal	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/23 12:24
40	189	photoresist with (lift off or liftoff) and polymer\$2 with substrate and metal and @PY< "2003"	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/23 12:24
41	12	photoresist with (lift off or liftoff) and polymer\$2 with substrate and metal and develop\$3 with (solvent or mechanical\$3)and dry with (oven or IR or hot gas\$2 or microwave or roller) and @PY<*2003*	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/23 12:25

542 	0	photoresist with (lift off or liftoff) and flexible with substrate and metal and develop\$3 with (solvent or mechanical\$3) and dry with (oven or IR or hot gas\$2 or microwave or roller) and @PY< 2003*	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/23 12:34
343	0	photoresist with (lift off or liftoff) and flexible with substrate and metal and develop\$3 with (solvent or mechanical\$3) and dry with (oven or IR or hot gas\$2 or microwave or roller) and @PY< 2004*	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/23 12:34
44	73	photoresist with (lift off or liftoff) and flexible with substrate and metal and develop\$3 and @Pr<"2004"	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/23 12:34
45	1721	(lithography or photoresist) with (lift off or liftoff) and (polymer\$2 or metal\$3 or glass or metal oxide) with substrate and @PY<*2004*	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/23 13:42
46	132	[lithography or photoresist) with (lift off or liftoff) and (polymer\$2 or metal\$3 or glass or metal oxide) with substrate and (sputter or evaporate) with (metal or half-metal) and @PY< "2004"	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/23 13:43
47	265	427/98.5.cds	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/23 14:01
48	95	427/98.5.cds. and (resist or photoinitiator)	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/23 14:02
49	26	427/98.5.cols. and (resist or photoinitiator) and plasma	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/23 14:03
50	2	10/502208.app.	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/02/23 15:36
51	2	"5320933" pn.	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/09/27 14:15

S52	18699	"circuit board" with ceramic	US-PGPUB; USPAT; FPPS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/09/27 14:34
S53	267	<sup>*</sup> circuit board* with ceramic with metallized	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/09/27 14:35
S54	66	("circuit board" with ceramic with metallized).ab.	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/09/27 14:35
S55	59	("Circuit board" with ceramic with metallized).ab. and @PY< 2004"	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/09/27 14:35
S57	1273	cur\$3 with (\$radiation or \$radiated radiation or UV or ultraviolet or ultra violet) with primer	US-PGPUB; USPAT; FPPS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/09/27 17:32
S58	29	cur\$3 with (\$radiation or \$radiated radiation or UV or ultraviolet or ultra violet) with primer with plasma	US-PGPUB; USPAT; FPPS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2009/09/27 17:32

<sup>9/28/2009 11:55:38</sup> AM

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